



AF 2814

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Letavie et al.)	Examiner: Ngo, N.
)	
Application No.: 10/015,640)	Art Unit: 2814
)	
Filed: 12/10/2001)	
)	
For: HIGH FREQUENCY HIGH VOLTAGE)	
SILICON-ON-INSULATOR DEVICE WITH)	
MASK VARIABLE INVERSION CHANNEL)	
AND METHOD FOR FORMING THE SAME)	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

After-Final Amendment

Sir:

Introductory Comments

In response to the Final Office Action of July 31, 2003, please amend the above-identified patent application as follows:

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